

Title (en)

METHOD AND DEVICE FOR COATING HIGH TEMPERATURE COMPONENTS BY MEANS OF PLASMA SPRAYING

Title (de)

VERFAHREN UND VORRICHTUNG ZUR BESCHICHTUNG VON HOCHTEMPERATURBAUTEILEN MITTELS PLASMASPRITZENS

Title (fr)

PROCEDE ET DISPOSITIF DE REVETEMENT DE COMPOSANTS HAUTE TEMPERATURE PAR PROJECTION AU PLASMA

Publication

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Application

**EP 99952248 A 19990803**

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Abstract (en)

[origin: DE19837400C1] The invention relates to a method for coating high temperature components (10) by means of plasma spraying. An infrared camera (20) is used to determine the thermal radiation distribution (30) of the component surface (40) and consequently the temperature distribution (70) used to adjust an operating parameter (p) in order to obtain a threshold temperature (Ts). The invention also relates to a coating device used to form a coating (14) and simultaneously control surface temperature with the infrared camera (20).

IPC 1-7

**C23C 4/12**

IPC 8 full level

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